

Electronic Patent Application Fee Transmittal

Application Number:	10586788
Filing Date:	02-Sep-2008
Title of Invention:	Plasma Excited Chemical Vapor Deposition Method Silicon/Oxygen/ Nitrogen-Containing-Material and Layered Assembly
First Named Inventor/Applicant Name:	Zvonimir Gabric
Filer:	Brian A. Carlson/Michelle Hatcher
Attorney Docket Number:	INF 2006 VJ 33543 US

Filed as Large Entity

U.S. National Stage under 35 USC 371 Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 1 month with \$0 paid	1251	1	130	130

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				940